

ket No 07977/286001/US5247

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S. Yamazaki, et al.

Art Unit :

1763

Serial No.: 09/966,689

Examiner :

Unknown

Filed

: September 27, 2001

Title

: DRY ETCHING APPARATUS, ETCHING METHOD AND METHOD OF

FORMING A WIRING

Commissioner for Patents Washington, D.C. 20231

4/2102

PRELIMINARY AMENDMENT

Prior to further examination, kindly amend the aboveidentified application as follows:

In the Specification:

Please replace the paragraph beginning page 10, line 6, with the following rewritten paragraph:

substrate.-
REMARKS

--FIGS. 21A and 21B show measurement points of a

Substrate.-
REMARKS

REMARKS

REMARKS

This Preliminary Amendment is filed to correct the figure description in the specification to correlate with the drawings

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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